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FACSIMILE COVER SHEET

To: Commissioner for Patents	Total Pages Sent: 3
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Facsimile Number: (571) 273-2885	Transmission Date: July 11, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Su, <i>et al.</i>	Docket No.:	TSM03-0150
Serial No:	10/675,862	Art Unit:	2823
Date Filed:	September 30, 2003	Examiner:	Fernando L. Toledo
Title:	Apparatus and Method for Manufacturing a Semiconductor Wafer with Reduced Delamination and Peeling		

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at (571) 273-2885 on the date shown above:

- Certification of Facsimile Transmission (1 page)
- Request for Confirmation of Information Disclosure Statement (1 page)
- Copy of PTO/SB/08a filed January 10, 2006 (1 page)

Respectfully submitted,

Kristin R. Hayes
Legal Assistant

Confirmation Respectfully Requested

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Su, *et al.* Docket No.: TSM03-0150
Serial No.: 10/675,862 Art Unit: 2823
Filed: September 30, 2003 Examiner: Toledo, Fernando L.
For: Apparatus and Method for Manufacturing a Semiconductor Wafer with
Reduced Delamination and Peeling

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR CONFIRMATION OF INFORMATION DISCLOSURE STATEMENT

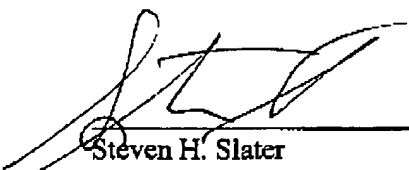
Dear Sir:

The patent application for the above-referenced patent application was allowed on June 21, 2006. An Information Disclosure Statement (copy attached) and the appropriate fees were filed by Applicant with the Amendment mailed January 10, 2006. However, Applicant did not receive confirmation of consideration of the Information Disclosure Statement by the Examiner with the Notice of Allowance. Applicant kindly requests that the Office forward the initialed copy of the PTO/SB/08A.

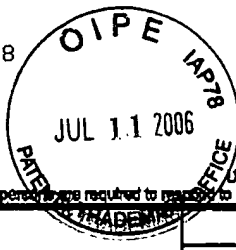
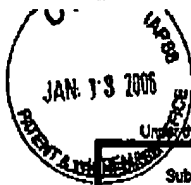
Respectfully submitted,

July 11, 2006

Date


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Attorney for Applicant
Reg. No. 35,361

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Complete if Known

Application Number	10/875,862
Filing Date	September 30, 2003
First Named Inventor	Su, et al.
Art Unit	2823
Examiner Name	Fernando L. Toledo
Attorney Docket Number	TSM03-0150

Sheet	1	of	1
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U.S. PATENT DOCUMENTS

[illegible]

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	3	PIDIN, S., <i>et al.</i> , "MOSFET Current Drive Optimization Using Silicon Nitride Capping Layer for 65-nm Technology Node," 2004 Symposium on VLSI Technology Digest of Technical Papers, pp. 54-55.	

Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 809. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. Applicant's unique citation designation number (optional). *See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 801.04. *Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). *For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. *Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 18 if possible. *Applicant is to place a check mark here if English language translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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